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Paper No: 10

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In re Application of:  
Rosenthal et al  
Filed: 25 November 1998  
Application No. 09/199,677  
Attorney Docket No. OLT-20  
For: THERMAL IMAGING FOR  
SEMICONDUCTOR PROCESS  
MONITORING

**COPY MAILED**

**FEB 4 2002**

**OFFICE OF PETITIONS  
ON PETITION**

This is a decision on the petition filed on December 7, 2001, under 37 C.F.R. §1.137(b) to revive the above-identified application.

This application became abandoned for failure to timely and properly file a response to a non-final Office Action as required in the Office Action, mailed January 26, 2001. A shortened statutory period for response was set to expire at three (3) months.<sup>1</sup> No reply was received within this time period.<sup>2</sup> Therefore, this application became abandoned for failure to timely file a proper reply as of April 26, 2001.<sup>3</sup>

A reply, the instantly filed amendment, in response to the Office Action of January 24, 2001 was filed on December 7, 2001 in conjunction with a Petition for Revival under 37 C.F.R. §1.137(b).

All other requirements for the filing of a grantable petition under 37 C.F.R. §1.137 have been met. Therefore, *this petition is **granted***.

This application will be forwarded to Technology Center 2800 for further processing.

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<sup>1</sup> 35 U.S.C. §133 and MPEP 710.02(b).

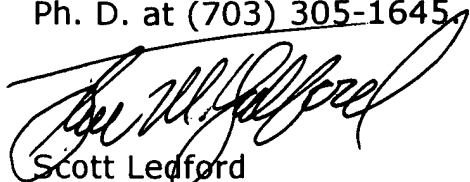
<sup>2</sup> Nor were any requests for extensions of time to respond to the non-final action received.

<sup>3</sup> 35 U.S.C. §133, 37 C.F.R. §1.134-136.

Applicant: Rosenthal et al  
Application No. 09/199,677

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Telephone inquiries concerning this matter may be directed to Susan Ungar,  
Ph. D. at (703) 305-1645

A handwritten signature in black ink, appearing to read "Scott Ledford", written over the printed name.

Scott Ledford  
Petitions Attorney  
Office of Petitions  
Office of the Deputy Commissioner  
for Patent Examination Policy